

Abstract

An electrically tunable Fabry-Perot structure using a deformable multi-layer mirror construction wherein $\text{Ga}_{1-a}\text{Al}_a\text{As}$, where $a < 0.1$, is used as the sacrificial layer which may be selectively removed using a citric acid etchant. The multi-layer mirrors consist of N and M period of quarter wavelength layers where N and M are integers, or integers plus $1/2$. Further, the mirrors are made from alternating layers of $\text{Ga}_{1-x}\text{Al}_x\text{As}$, where $x > 0.96$, and a material selected from the group consisting of either $\text{Ga}_{1-z}\text{Al}_z\text{As}$, where $0.7 > z > 0$, or $\text{Ga}_{1-y}\text{Al}_y\text{As}/\text{Ga}_{1-z}\text{Al}_z\text{As}/\text{Ga}_{1-y}\text{Al}_y\text{As}$, where $0.7 > z > 0$ and $y > 0.5$. The $\text{Ga}_{1-x}\text{Al}_x\text{As}$ is wet oxidized by exposing its edge to water in a nitrogen or helium atmosphere at a temperature of between about 360°C and 450°C so as to transform it to AlO_x . The resulting AlO_x layers abut the sacrificial layer and act as etch stops during the formation of a cantilever Fabry-Perot structure by etching of the sacrificial layer.